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|   | Filing Date            |       | 2000-10-30      |  |
|   | First Named Inventor   | Berge | eron            |  |
|   | Art Unit               |       | 1796            |  |
|   | Examiner Name          | Chung | g               |  |
|   | Attorney Docket Number | er    | 8439.004.USCP00 |  |

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| First Named Inventor   | Berge | Bergeron        |  |  |  |  |
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| Examiner Name          | Chung |                 |  |  |  |  |
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